

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Shinji MAEKAWA et al. )  
Japanese Priority Application No. 2002-340167 ) Attn: Applications  
Japanese Priority Date: November 22, 2002 ) Branch  
For: METHOD FOR FABRICATING )  
THIN FILM TRANSISTOR ) Date: November 17, 2003

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please preliminarily amend the subject application as follows: